AMENDMENTS TO THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

LISTING OF CLAIMS:

1. (Currently Amended) An apparatus, comprising[[,]]:

a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate; an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer and

wherein said first and second electrodes are in contact with opposite surfaces sides of said electrode insulating layer.

Claims 2-3 (Canceled)

(Currently Amended) The apparatus of Claim 3, An apparatus, comprising: 4. a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating layer located on said top surface:

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer; said self-assembled layer comprises a stack of at least two self-assembled layers, said stack comprising an end group of a first organic molecule in a first self-assembled layer chemically coupled to an end group of a second organic molecule in a second self-assembled layer; and wherein said coupling between said end groups of said first and second organic molecules includes a copper bridge.

- (Original) The apparatus of Claim 1, wherein said self-assembled layer comprises 5. non-conductive organic molecules.
 - (Currently Amended) The apparatus of Claim 1, An apparatus, comprising: 6. a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer and wherein said self-assembled layer comprises semiconductive organic molecules.

> 7. (Currently Amended) The apparatus of Claim 1, An apparatus, comprising: a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer and wherein said self-assembled layer is covalently bonded to said lateral surface.

8. (Currently Amended) The apparatus of Claim-1, An apparatus, comprising: a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer and wherein said self-assembled layer comprises a channel and said apparatus comprises an organic field effect transistor, wherein said channel has a charge mobility of at least about 1×10^{-3} cm² V⁻¹ s⁻¹.

 (Original) The apparatus of Claim 1, wherein a footprint of said electrode insulating layer is substantially aligned with said top surface.

Claims 10-20 (Canceled)

21. (Currently Amended) The apparatus of Claim 1, An apparatus, comprising:

a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top
surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;
an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer; said first and second electrodes are in contact with opposite surfaces of said electrode insulating layer; and wherein said second electrode overhangs said first electrode.

22. (Currently Amended) The apparatus of Claim 1, An apparatus, comprising:

a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top
surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;
an electrode insulating layer located on said top surface;

a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer; said first and second electrodes are in contact with opposite surfaces of said electrode insulating layer; and wherein a thickness of said electrode insulating layer is greater than a separation distance between said first electrode and said second electrode.

23. (Currently Amended) The apparatus of Claim 1, An apparatus, comprising:
a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating layer located on said top surface; a self-assembled layer located on said lateral surface; and

wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer; said first and second electrodes are in contact with opposite surfaces of said electrode insulating layer; and wherein a thickness of said electrode insulating layer is less than about 500 nanometers.

24. (Currently Amended) The apparatus of Claim 1, An apparatus, comprising:

a substrate having a planar surface

first and second electrodes located on said planar surface, said first electrode having a top surface and a lateral surface, said lateral surface having an edge near or in contact with said substrate;

an electrode insulating laver located on said top surface;

a self-assembled layer located on said lateral surface; and

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wherein said second electrode is in contact with both said self-assembled layer and said electrode insulating layer; said first and second electrodes are in contact with opposite surfaces of said electrode insulating layer; and wherein said first electrode and said second electrode are separated by a distance of less than about 5 nanometers.